

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	7371	anti\$1static near3 (((cinematographic radiographic photographic) adj film) film)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 20:21
L2	81	1 and (static near3 (trouble defect outbreak))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:07
L3	61	2 and (simulat\$3 measur\$3 test\$3)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 20:22
L4	6	3 and (electrostatic near3 charge) and ((surface near3 resistivity) (surface near3 resistance))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:00



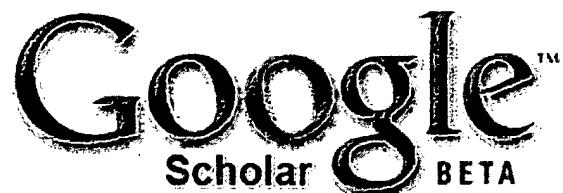
WPF
04/04/2007

EAST Search History

L5	2	(step\$1wise with (chang\$3 alter\$5 differ\$4)) same (electrostatic near3 charge) same ((surface near3 resistivity) (surface near3 resistance))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:02
L6	1	1 and 5	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:02
L7	1	5 not 6	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:03
L8	6406	((427/8) or (427/458) or (427/470) or (427/471) or (427/160) or (427/412.1) or (427/419) or (427/419.1) or (427/419.2) or (427/419.3) or (427/419.5)).CCLS.	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	OFF	2007/04/04 21:04
L10	33	1 and 8	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:06

EAST Search History

L11	1	10 and simulat\$3	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:06
L12	2	8 and (static near3 (trouble defect outbreak))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/04 21:07



Search Results Attached

Serial Number 10/682,540

Date 04/04/2007

Total Pages of Results 2

WPT
04/04/2007



Web Images Video News Maps more »
("static marks" OR "static defects") AND (phot Search

© Search only in Chemistry and Materials Science.

○ Search in all subject areas.

The "AND" operator is unnecessary -- we include all search terms by default. [details]

Scholar Results 1 - 5 of 5 for ("static marks" OR "static defects") AND (photographic OR radiographic OR cinematic) AND (anti-static OR antistatic) AND (simulation OR test OR simu

All Results

M Takimoto

Photosensitive materials having improved antistatic property - group of 2 »

T Miyazako, I Toriya, M Hirose, ... - US Patent 4,126,467, 1985 - Google Patents

... photosensi- static marks are more likely to be generated. ... sensitive ing photographic properties. ... without unproved antistatic property which comprises a sup- ...

Cited by 59 - Related Articles - Web Search

Silver halide photographic materials having improved anti-static properties - group of 2 »

T Miyazako, I Toriya, M Hirose, ... - US Patent 4,126,467, 1985 - Google Patents

... static marks was carried out by placing a sample ofthe ... on the sup- 65 unexposed photographic material on ... with the anti-static layer coated surface of the photo ...

Cited by 4 - Related Articles - Web Search

Photographic film with base containing polymeric antistatic material - group of 2 »

J Greener, D Majumdar, TM Laney - US Patent 6,207,361, 2001 - Google Patents

... one extruded layer comprising a polymeric anti-static material. ... fog pat -tems or "static marks" in the ... as antistatic layers in photographic films comprising a ...

Cited by 5 - Related Articles - Web Search

Imaging element comprising an electrically-conductive layer containing conductive fine particles, a ... - group of 3 »

CC Anderson, Y Wang, JL Bello, IM Shalhoub, DD ... - US Patent 5,466,567, 1995 - Google Patents

... s) can produce irregular fog pat -tems or "static marks" inthe emulsion. ... 4,078,935) as being useful in antistatic layers for photographic applications. ...

Cited by 19 - Related Articles - Web Search

Imaging element comprising an electrically-conductive layer exhibiting improved adhesive ... - group of 3 »

M Lelelial, J Greener - US Patent 5,508,135, 1996 - Google Patents

... s) can produce irregular fog pat -tems or "static marks" inthe emulsion. ... 4,078,935) as being useful in antistatic layers for photographic applications. ...

Cited by 8 - Related Articles - Web Search

("static marks" OR "static defects") / Search

